## Notice of References Cited Application/Control No. 10/695,396 Examiner David Y. Chung Applicant(s)/Patent Under Reexamination KIM ET AL. Art Unit Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,300,926	10-2001	Yoneya et al.	345/87
	В	US-			
	O	US-			
	Ď	US-			
	E	US-			
	F	US-			
	G	US-		*	
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	J	us-			
	К	US-			
	٦	US-			
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## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification	
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## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)						
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